

Picosecond Laser Krypton Plasma Emission in Water-Window Spectral Range



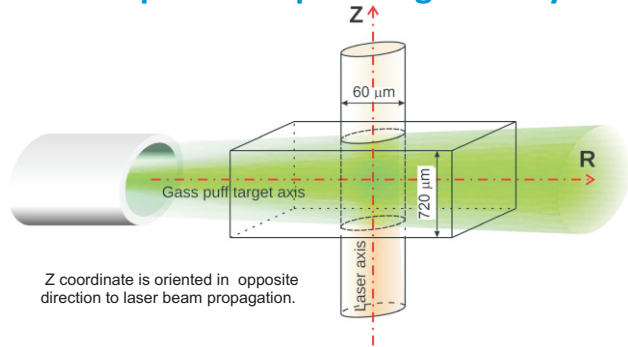
P. Vrba, Institute of Plasma Physics, Czech Acad. Sci., 182 00 Prague 8, CR,
M. Vrbova, Czech Technical University, Faculty of Biomedical Engineering, 272 01 Kladno, CR



Introduction

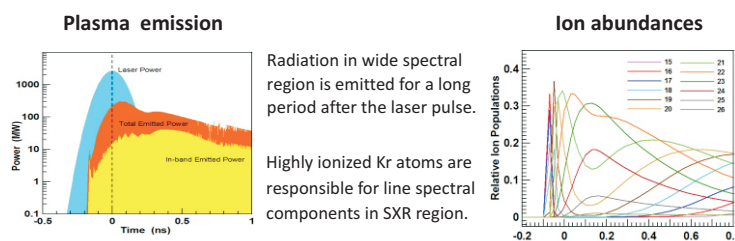
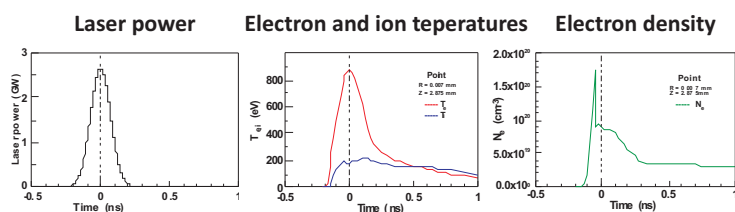
Laser plasma created in krypton gas puff target is studied as a source of radiation in the water window spectral range. Spatial development of plasma induced by Nd:YAG laser pulse (170 ps/480 mJ) with peak power density 10^{14} W cm⁻², incident on the gas-puff target is modeled using 2D RMHD code Z^{*} [1].

Gas puff laser plasma geometry

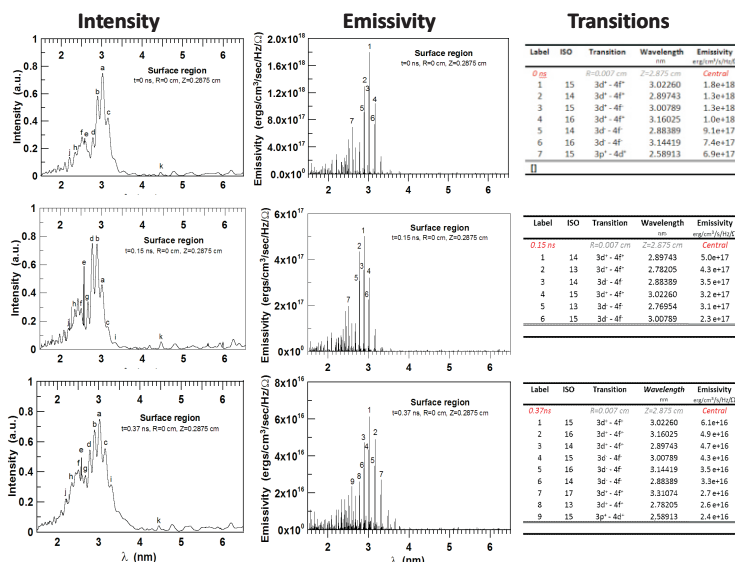


Time dependences

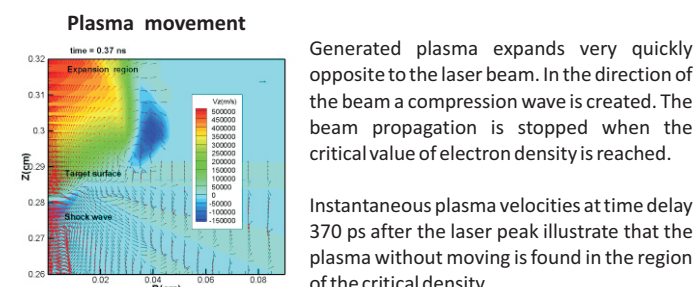
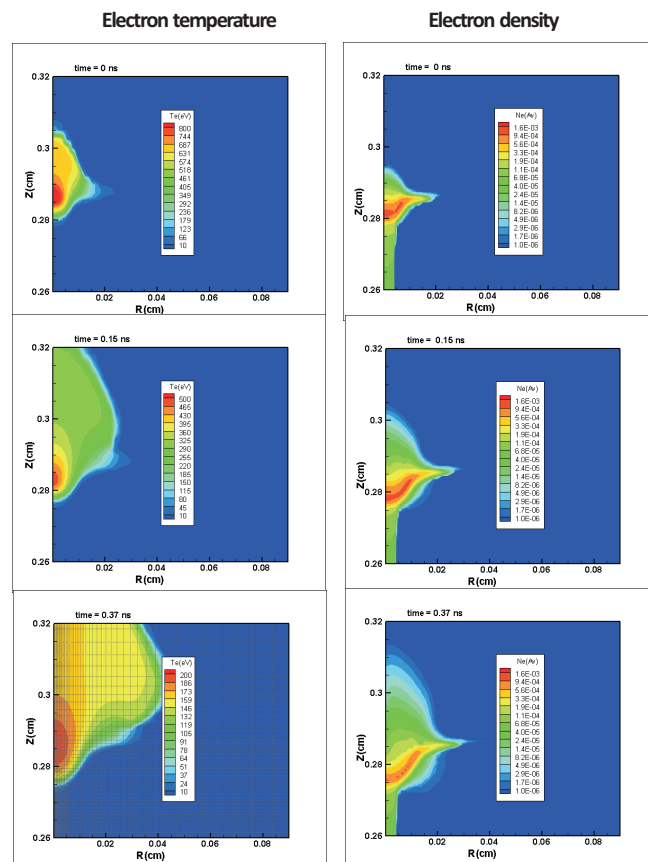
The time dependences of plasma electron temperature and electron density in representative points are introduced into the kinetic code FLYCHK [2].



Instantaneous spectra estimation



Spatial evolution of plasma



Generated plasma expands very quickly opposite to the laser beam. In the direction of the beam a compression wave is created. The beam propagation is stopped when the critical value of electron density is reached.

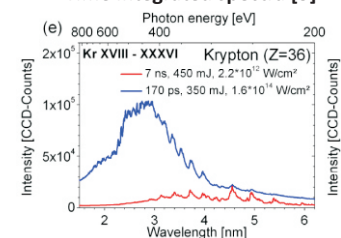
Instantaneous plasma velocities at time delay 370 ps after the laser peak illustrate that the plasma without moving is found in the region of the critical density.

Conclusion

Our computer model of laser plasma indicates that the spectrum of emitted radiation is changing very fast, not only during the laser pulse, but also over a long period after the pulse.

Time integrated spectra in the spectral range 2 – 6 nm [3] measured under the same conditions as those used for modeling are adequate. The highest emissivities correspond to quantum transitions of ions Kr²⁰, Kr²¹, Kr²² and Kr²³. The krypton laser plasma et ~ 150 eV may be also considered as a possible candidates for source of water window radiation [4].

Time integrated spectra [3]



References

- [1] S.V. Zakharov et al., in EUV Source for Lithography, SPIE Press 2005, p. 223.
- [2] H.-K. Chung, et al., High Energy Density Physics, Vol. 1, p.3 (2005).
- [3] M. Muller, et al., Optics Express, 2013, 21(10) DOI: 10.1364/oe.21.012831.
- [4] V.S. Zakharov, Proc. 2013, Int. Workshop on EUV and SXR Sources, Dublin, Ireland.

Acknowledgments

This work was partially supported by a grant of Ministry of Education, Youth and Sports CR on the project LG15013 Research in the Frame of the International Centre for Dense Magnetized Plasmas. The numerical evaluations were supported in the frame of institutional financing Laser Plasma IPP CAS CR.